El-Kareh

Silicon Devices and Process Integration

Deep Submicron and Nano-Scale Technologies

This book includes discussion of silicon materials and electrical engineering properties as used in the design of analog components. Due to the author's background at Texas Instruments, the book will have an emphasis on newer process integration techniques and technology to help professional engineers in the field understand and develop electrical components.

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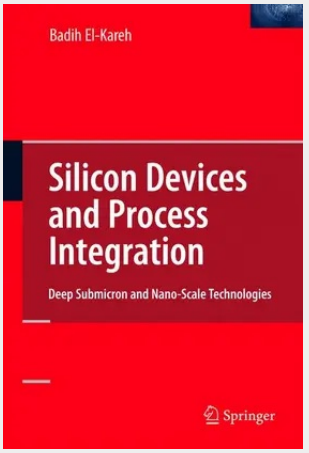

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